

## Electronic Patent Application Fee Transmittal

<b>Application Number:</b>	10772740
<b>Filing Date:</b>	05-Feb-2004
<b>Title of Invention:</b>	METHOD OF PLASMA ENHANCED CHEMICAL VAPOR DEPOSITION OF DIAMOND USING METHANOL-BASED SOLUTIONS
<b>First Named Inventor/Applicant Name:</b>	Yonhua Tzeng
<b>Filer:</b>	Jonathan O Owens
<b>Attorney Docket Number:</b>	220101-1011

Filed as Small Entity

### Utility under 35 USC 111(a) Filing Fees

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
<b>Basic Filing:</b>				
<b>Pages:</b>				
<b>Claims:</b>				
<b>Miscellaneous-Filing:</b>				
<b>Petition:</b>				
<b>Patent-Appeals-and-Interference:</b>				
<b>Post-Allowance-and-Post-Issuance:</b>				
Utility Appl issue fee	2501	1	755	755
Publ. Fee- early, voluntary, or normal	1504	1	300	300

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
<b>Extension-of-Time:</b>				
<b>Miscellaneous:</b>				
Printed copy of patent - no color	8001	10	3	30
<b>Total in USD (\$)</b>				<b>1085</b>